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Bib Data Sheet

CONFIRMATION NO. 2896

SERIAL NUMBER 09/767,659	FILING DATE 01/22/2001  RULE	CLASS 414	GROUP ART UNIT 3652	ATTORNEY DOCKET NO. A-67736-1/AJT/MSS
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## APPLICANTS

Richard N. Savage, Scotts Valley, CA;

Frank S. Menagh, Santa Cruz, CA;  
Helder R. Carvalheria, Scotts Valley, CA; Philip A. Troiani, Santa Cruz, CA;  
Dan L. Cossentine, Santa Cruz, CA;  
Eric R. Vaughan, Santa Cruz, CA;  
Bruce E. Mayer, Soquel, CA;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/483,945 01/13/2000 PAT 6,610,150  
and claims benefit of 60/127,532 04/02/1999  
and claims benefit of 60/127,650 04/02/1999

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 04/23/2001

Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 16	TOTAL CLAIMS 6	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

## ADDRESS

Maria S. Swiatek  
FLEHR HOHBACH TEST ALBRITTON & HERBERT LLP  
Four Embarcadero Center, Suite 3400  
San Francisco, CA  
94111-4187

## TITLE

Semiconductor wafer processing system with vertically-stacked process chambers and single-axis dual-wafer transfer system

☐ All Fees



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UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
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<input type="checkbox"/> 1.18 Fees ( Issue )
<input type="checkbox"/> Other _____
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